

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
PATENT APPLICATION**

In re Application of:

**Steven K. Mayes**

Docket: **TI-30344.1**

Serial No.: **10/804,362**

Art Unit: **2856**

Filed: **03/18/2004**

Examiner: **R. Frank**

Confirmation No.: **9234**

For: **METHOD AND SYSTEM FOR PROCESSING SEMICONDUCTOR WAFERS**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**EXTENSION OF TIME**

Sir:

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner for an extension of the shortened statutory period in the above-referenced application.

The fee for this extension is indicated below:

One Month (\$120)

Please charge the fee to Deposit Account No. 20-0668. Any further necessary extension of time is hereby requested. Charge any additional fee or credit any overpayment to Deposit Account No. 20-0668.

Respectfully submitted,

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/Yingsheng Tung/  
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